



PATENT
P-US080-A-MF

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Cohen, et al. Customer No: 32107
Assignee: Microfabrica Inc. Docket No: P-US024-A-MF
Title: Method for Electrochemically Forming Structures Including Non-Parallel Mating of Contact Masks and Substrates
Application No: 10/724,515 Filing Date: November 26, 2003
Examiner: Culbert, Roberts P. Group Art Unit: 1763

COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

May 19, 2006

AMENDMENT

Dear Sir:

Applicant makes this submission in response to the Office action dated December 19, 2005 for the above noted application for which the period of response has been extended to May 19, 2006 by a petition for extension of time and the fee submitted herewith.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 10 of this paper.